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APPLICANTS

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** CONTINUING DATA ***** *del*

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2002-84281 12/26/2002
 REPUBLIC OF KOREA 2002-65754 10/28/2002 *OK*
 REPUBLIC OF KOREA 2002-65753 10/28/2002

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>del</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 8	TOTAL CLAIMS 18	INDEPENDENT CLAIMS 3
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TITLE
 Method of forming isolation films in semiconductor devices

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of
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